

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TAKEI et al.

Application No.: New U.S. National Phase of
PCT/JP2004/019225

Filed: June 23, 2006

Docket No.: 128515

For: COMPOSITION FOR FORMING NITRIDE COATING FILM FOR HARD MASK

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.